

2003

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10003179	FILING DATE 10/31/2001	CLASS 422	SUBCLASS 645	GAU 	EXAMINER Najina
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**APPLICANTS: Watanabe Tadaharu; Fraenkel Dan;

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**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB <input type="checkbox"/>	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO MTG009
Verified and Acknowledged Examiners's initials		

TITLE : Materials and method for the purification of hydride gases

U.S. DEPT. OF COMM./PAT. & TM.-PTO-4361 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drawg.	Figs. Drawg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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